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Effect of pulse parameter change on a-SiCN diaphragms for environmental cells fabricated by magnetic-field- and pulsed-plasma-enhanced chemical vapor deposition

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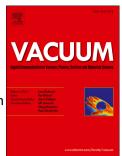
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Title:

Effect of Pulse Parameter Change on a-SiCN Diaphragms for Environmental Cells Fabricated by Magnetic-Field- and Pulsed-Plasma-Enhanced Chemical Vapor Deposition

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